

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Koichiro Shoji

Application No.: 10/501,155

Confirmation No.: 5207

Filed: July 13, 2004

Art Unit: 1792

For: SURFACE TREATMENT METHOD,
SEMICONDUCTOR DEVICE, METHOD OF
FABRICATION SEMICONDUCTOR DEVICE
AND TREATMENT APPARATUS

Examiner: J. L. Watson

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 11, 2008, finally rejecting claims 1-36 and 42-53, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.